

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

HONG et al.

Atty. Ref.: 2826-9

Serial No. unknown

Group:

Filed: January 17, 2002

Examiner:

For: METHOD AND APPARATUS FOR CUTTING A MULTI-LAYER SUBSTRATE
BY DUAL LASER IRRADIATION

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January 17, 2002

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

PRELIMINARY AMENDMENT

In order to place the above-identified application in better condition for
examination, please amend the application as follows:

IN THE CLAIMS

Please substitute the following amended claims for corresponding claims
previously presented. A copy of the amended claims showing current revisions is
attached.